



Response Under 37 C.F.R. § 1.116

Expedited Procedure

Examining Group 3723

PATENT

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Hg/A
DS*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)

Cangshan XU et al.)

Application No. 09/752,509)

Filed: December 27, 2000)

For: METHODS FOR MAKING)
REINFORCED WAFER POLISHING)
PADS AND APPARATUSES)
IMPLEMENTING THE SAME)

Examiner: Nguyen, Dung V.

Art Unit: 3723

Docket No. LAM2P223A

Date: November 19, 2002

*Please enter
DVN
12-19-02*

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on November 19, 2002.

Signed:

Diane Schwanbeck
Diane Schwanbeck

AMENDMENT

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NOV 29 2002

TECHNOLOGY CENTER R3700

Commissioner for Patents
Box AF
Washington, D.C. 20231

Sir:

This paper is in response to the Office Action dated August 19, 2002. A response to this Office Action is due on November 19, 2002. Please enter the following amendment and remarks:

IN THE SPECIFICATION

Please add the following section to page 1, line 7 (before the beginning of the "BACKGROUND OF THE INVENTION" section) of the specification as filed:

X



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Response Under 37 C.F.R. § 1.116
Expedited Procedure
Examining Group 3723
PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Attorney Docket No. LAM2P223A
Cangshan XU et al.)
Application No. 09/752,509) Examiner: Dung V. Nguyen
Filed: December 27, 2000) Group Art Unit: 3723
For: METHODS FOR MAKING REINFORCED) Date: November 19, 2002
WAFER POLISHING PADS AND)
APPARATUSES IMPLEMENTING THE SAME)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on November 19, 2002.

Signed:

Diane Schwanbeck

Commissioner for Patents
Box AF
Washington, DC 20231

Sir:

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NOV 29 2002

Applicants transmit herewith a Proposed Amendment in the above-identified application. **TECHNOLOGY CENTER R3700**
The fee has been calculated as shown below.

	Claims Remaining After <u>Amendment</u>	Highest Previously <u>Paid For</u>	Present <u>Extra</u>	SMALL ENTITY <u>RATE FEE</u>	OR	LARGE ENTITY <u>RATE FEE</u>
TOTAL CLAIMS	<u>35</u> -	<u>35</u>	<u>00</u>	X09 = \$	OR	X18 = \$
INDEP CLAIMS	<u>09</u> -	<u>09</u>	<u>00</u>	X42 = \$	OR	X84 = \$
			TOTAL	\$ _____		\$0

Applicants hereby petition for a ____-month extension of time to respond to the Office Action.
Applicants believe that no extension of time is required; however, if it is determined that such an extension is required, Applicants hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an extension of time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM2P223A).

Enclosed is our Check No. ____ in the amount of \$____ to cover the extension of time fees.
If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P223A). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE & PENILLA, LLP

Edmund H. Mizumoto, Esq.
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